

ABSTRACT OF THE DISCLOSURE

The invention discloses a stacked piezoelectric element comprising a plurality of piezoelectric layers and electrode layers stacked alternately in which the 5 electrode layers are electrically connected by a penetrating electrode formed in a conductive hole formed in a direction of the thickness of the piezoelectric layers, and in which the penetrating electrode formed in a piezoelectric layer of a first 10 layer is so positioned as to overlap with the penetrating electrode formed in a piezoelectric layer of a first layer in the direction of thickness.